



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Shin Seung Park

Serial No.:

10/735,228

Filed:

December 12, 2003

Title:

METHOD OF FORMING METAL

LINE OF SEMICONDUCTOR

**DEVICE** 

Group Art Unit:

1765

Examiner: To be assigned

Attorney Docket No.: 29936/39847

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on December 13, 2004.

lip H. Patel (Reg. No. 43,848)

Attorney for Applicants

## **STATUS INQUIRY**

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

The above-identified patent application was filed on December 12, 2003.

Please advise when an official action on the merits can be expected.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

December 13, 2004

By:

Sandip H. Patel (Reg. No. 43,848)

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